

Application No.: 10/522,279



KIT 383-US (10500694)
(PATENT)

If-w/Engr

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Fujita

Application No.: 10/522,279

Confirmation No.: @@@

Filed: January 24, 2005

Art Unit: N/A

For: METHOD AND APPARATUS FOR
CULTURING PLANT

Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

A summary/abstract translation of the non-English language references is enclosed for some of the references.

A copy of each reference on the PTO/SB/08 is attached.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0624, under Order No. NY-KIT 383-US.

Respectfully submitted,

By 

C. Andrew Im

Registration No.: 40,657

FULBRIGHT & JAWORSKI L.L.P.

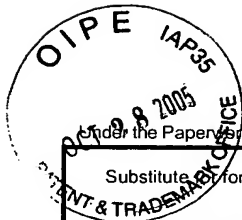
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PTO/SB/08A (10-01)

Approved for use through 10/31/2002.OMB 0651-0031

U. S. Patent and Trademark Office: U. S. DEPARTMENT OF COMMERCE

Substitute Form 1449A/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

Application Number	10/522,279
Filing Date	January 24, 2005
First Named Inventor	Fujita
Art Unit	N/A
Examiner Name	Not Yet Assigned
Attorney Docket Number	NY-KIT 383 US (10500694)

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	AA	US-5,858,309	01/12/99	Mathus, et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	BA	JP-09-033411 A	02/07/97	Nitto Shoji KK		
	BB	JP-2002-139418 A	05/17/02	Nikon Corp.		
	BC	JP-2-7553	01/18/90	Aloka Co., Ltd.		
	BD	JP-3-69852 B2	11/05/91	Toshiba Corp.		
	BE	JP-08-129014 A	05/21/96	Dainippon Ink and Chem. Inc. et al.		
	BF	JP-6-95073 B2	11/24/94	Dir. General, Agency of Industrial Science and Technology		
	BG	WO-01/62887 A1	08/30/01	Zyomyx, Inc.		✓
	BH	JP-7-2955	01/17/95	Aloka Co., Ltd		✓
	BI	JP-10078388	03/24/98	Corning Costar Corp.		
	BK	JP-2003-524193 A	08/12/03	Zyomyx, Inc.		✓
	BL	EP-797088 A	03/1998	Corning Costrar Corp.		✓
	BM	JP 59-15839	01/1984	Toshiba Corp.		
						✓
						✓
						✓

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¹ Applicant's unique citation designation number (optional). ² See attached Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Examiner Signature		Date Considered	
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